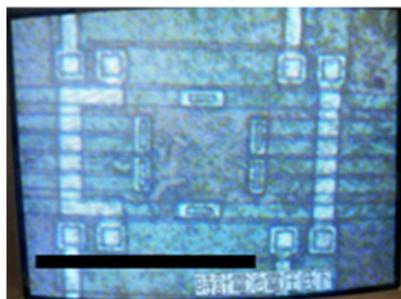


Supplementary Materials: Adsorption Kinetics of Polystyrene and Poly(9-anthracenyl methyl methacrylate) onto SiO₂ Surface Measured by the Chip Nano-Calorimetry

Mina Ishihara, Tomoya Watanabe and Takashi Sasaki

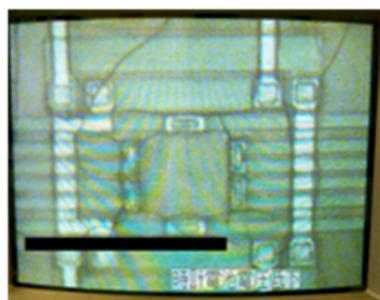
S1. Morphology of the prepared films of PAMMA



Sample #1



Sample #2



Sample #3



Sample #4

Figure S1. Optical micrographs of typical PAMMA films on the active area of the chip sensor after annealing at 433 K for ca. 10⁶ s. The scale bar indicates 70 μm.